

<b>Notice of References Cited</b>	Application/Control No. 09/683,345	Applicant(s)/Patent Under Reexamination MCNULTY ET AL.	
	Examiner Edwin A. León	Art Unit 2833	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,023,371	02-2000	Onitsuka et al.	359/620
	C	US-5,717,289	02-1998	Tanaka, Taizou	313/503
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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